

SEP 1 6 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Ølicant: Anis Zribi et al.

Group Art Unit: 2855

Serial No.:

10/719.971

Examiner: M. Cygan

Filed: November 21, 2003

For MINIATURIZED MULTI-GAS AND VAPOR

SENSOR DEVICES AND ASSOCIATED

ALEXANDRIA, VA 22313-1450

METHODS OF FABRICATION

INFORMATION DISCLOSURE STATEMENT

<u> </u>	Pursuant to 37CFR 1.97(b) [within 3 months of national, non-CPA filling or prior to 1st Office Action] no charge
X 2	Certification Pursuant to 37 CFR 1.97(c)(1) [before Final Office Action, Allowance, or other action closing prosecution] no charge
<u> </u>	Fee Payment Pursuant to 37 CFR 1.97(c)(2) [before Final Office Action, Allowance, or other action closing prosecution] \$180.00
4	Certification & Fee Payment Pursuant to 37 CFR 1.97(d) [On or before issue fee payment] \$180.00
ATTN:	Mail Stop AMENDMENT COMMISSIONER FOR PATENTS PO Box 1450

Sir:

The following are submitted in the above application in compliance with 37 CFR 1.97 and 37 CFR 1.98:

 ∑ 5 A list of documents on form PTO-1449 or Substitute together with copies of each identified document and a translation thereof or a concise explanation of each non-English language document or a Search Report from an International Searching Authority for a patent application filed via the Patent Cooperation Treaty or document(s) cited in the application or the priority application.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on the date indicated below.
Jen Date of Deposity Yers
Oear Myus

This paper is subm	itted in accordance with:	
□ 6	37 CFR 1.97(b): [within 3 Action]	months of national, non-CPA filing or prior to 1st Office
∑ 7	37 CFR 1.97(c): [before F closing prosecution, which	final Office Action, Allowance, or other action lever is earlier]; and
	8 The required Certific	cation made in item 11 below;
Ε		ecified in 37 CFR 1.17(p) for submission of closure Statement is authorized in item 15 below.
□ 10	37 CFR 1.97(d): [on or be	fore issue fee payment]; and
	a) The required Certific	ation is stated in item 11 below; and
	•	ecified in 37 CFR 1.17(p) for submission of closure Statement is authorized in item 14 below.
11	Certification	
	any communication	nation contained in this Statement was first cited in from a foreign patent office in a counterpart lication not more than three months prior to the ent; or
	from a foreign pater to the knowledge of reasonable inquiry Statement was know	in this Statement was cited in a communication of the person signing this document after making , no item of information contained in this own to any individual designated in 37 CFR three (3) months prior to the filing date of this
⊠ 14	Payment of all applicable f	fees:
Σ		applicable fees associated with the submittal of sclosure Statement to Deposit Account No.
An original and two	(2) copies of this documen	t are enclosed.
9	/12/05	Attorney Will F. P. II
General Electric Com GEGR Patent Docket One Research Circle	Rm. Bldg. K-1 Rm. 4A59	Attorney - William E. Powell Registration No. 39,803 Phone: (518) 387-4530 or (518) 387-7122

Niskayuna, New York 12309 Customer Number: 006147

(REV. 7-80) (Title Amended		PATENT AND TRADEMARK OFFICE (3)										132669		SERIAL NO. 10/719,971			
INFORMAJ		ISC	LC	SL	JRE	ΞS	ТА	TE	MENT BY A	APPLICANT-		Applicant					
INFORMATION DISCLOSURE STATEMENT BY LIST OF ITEMS												Anis Zribi et al.		_			
0005											Filing Date		Group				
SEP 1 6 2005 (Use several sheets if necessary)									necessary)		November 21, 20	003	2855	ĺ			
EXAMINER .	SER !									U.S. PATEN	TC	DOCUMENTS					
'EXAMINER INITIAL		DOCUMENT NUMBER DATE										NAME	CLASS	SUBCLASS		G DATE ROPRIATE	
	AA										she	er					
•	AB	5	5 6 5 9 1 2 7 08/19/97 Shie et al.							Shie et al.						100,100	
	AC	6	1	9	3	4	1	3	02/27/01	Liebermar	n						
•	AD																
	AE																
	AF			L													
	AG	AG															
	АН																
	Al		·														
	AJ																
-	AK																
	4 2				•				FOREIG	N PATENT D)0(CUMENTS					
		DC	ocu	MEN	NT N	IUM	BER		DATE			OUNTRY	CLASS	SUBCLASS	TRANS YES	LATION No	
	AL	0 1 3 4 2 9 0					9	0	11/09/00	PCT							
	AM		0 7	7 0) 3	4	4	9	09/20/95	EPO							
	AN																
	AO																
	AP																
				0	ТН	ER	INF	OF	RMATION (In	cluding Autho	or,	Title, Date, Pertinent p	pages. Etc	;.)		.	
	AR	OTHER INFORMATION (Including Author, Title, Date, Pertinent pages. Etc.) US2002/017126 A1, Frank Dimeo et al. Feb. 14, 2002															
	AS	US 2003/101006 A1, P. Mansky et al. May 2003															
	ΑT	"A Substrate for Thin-film Gas Sensors in Microelectronic Technology", U. Dibbern, Sensors and Actuators B (Chemical) Switzerland, Vol. 82, No. 1, March 1990															
EXAMINER		•				•			· <u> </u>	DA	۱TE	CONSIDERED					
*EXAMINER: Initi	ial if refe is form w	rence vith ne	con:	side	red,	whe catio	ther n to	or no	ot citation is in co	onformance with N	MPE	EP 609; Draw line through cit	ation if not in	conformance ar	nd not consid	dered.	

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV. 7-80) PATENT AND TRADEMARK OFFICE (Title Amended 3/83)										132669	S	SERIAL NO. 10/719,971			
INFORMAT	ION D						MENT BY	'APPLICAN	T	Applicant Anis Zribi e	et al.				
		<u>L</u>	<u>IST</u>	OF	ITEN	<u> 15</u>			Filing Date		G	Group			
	1	(Use	seve	eral s	sheet	s if	necessary))	November	21, 2003		2855			
					***************************************			U.S. PATE	ENT	DOCUMENTS					
*EXAMINER INITIAL	С	OCUM	/ENT	NUME	3ER	_	DATE			NAME	CLASS	SUB	BCLASS		G DATE ROPRIATE
_	ВА	\coprod	\perp		Щ	\perp	<u> </u>								
•	ВВ	Ц			Щ										
	вс													<u> </u>	
•	BD		$\overline{\perp}$			I			_						
	BE										1 8 1				
	BF														
15	ВG	\prod		\prod								74			
	вн														
	ВІ	\prod		\Box								1			
	ВЈ	1													
	вк	$\dag \uparrow$	T	\prod	+										
						Щ.	FORE	EIGN PATENT	ΓDO	CUMENTS	1				
		DOC	CUME	NT N	UMBE	R	DATE		С	COUNTRY	CLASS	SUBC	CLASS	TRANSI YES	LATION No
	BL														
	ВМ														
	ви								_						
	во		\prod												
	ВР		\prod	1											
		•	(THE	ER IN	1FO	RMATION	(Including Au	thor,	Title, Date, Perti	inent pages. E	tc.)	•		<u>}</u>
	BR	"Micromachined CMOS Calorimetric Chemical Sensor with On-Chip Low Nose Amplifier", A. Koll et al., MicroElectro Mechanical Systems, 1999, Piscataway, NJ, Jan. 1999, pps. 547-551													oll
	BS														
	вт														
EXAMINER								1	DAT	E CONSIDERED)				
*EXAMINER: Init Include copy of th	tial if refer	ence c	conside	ered, r	whethe	er or r	not citation is in	n conformance wi	ith MP	PEP 609; Draw line three	ough citation if not	in conforr	nance an	ıd not consid	dered.